



PATENT

Customer No. 22,852
Attorney Docket No. 7553.0008

AF #

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Chishio KOSHIMIZU et al.) Group Art Unit: 1765 ✓
Application No: 09/665,940) Examiner: L. UMEZ ERONINI
Filed: September 21, 2000)
For: PLASMA PROCESSING)
APPARATUS AND PLASMA)
PROCESSING METHOD)

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a one month extension of time to reply to the Office Action of August 27, 2003. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: December 4, 2003

By: 
Michael W. Kim
Reg. No. 51,880

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